

## PATENT ASSIGNMENT COVER SHEET

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<b>Name:</b>	National Science Foundation
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<b>State/Country:</b>	VIRGINIA
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<b>PROPERTY NUMBERS Total: 1</b>	
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<b>Application Number:</b>	14453235
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Invention Title: RF-Enabled High-Brightness Ultrafast Electron Microscope

Inventor(s): Martin M Berz, Chong-Yu Ruan, Zhensheng Tao

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Patent or Application Serial No.: 14/453,235

Grant/Contract Number(s): DMR1126343

Foreign Applications filed/intended in (countries): \_\_\_\_\_

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this 27<sup>th</sup> day of October, 20 14.

By Richard W. Chylla  
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